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| APPLICATION NUMBER | FILING OR 371(c) DATE | FIRST NAMED APPLICANT | ATTY. DOCKET NO./TITLE |
|--------------------|-----------------------|-----------------------|------------------------|
| 10/594,174 | 09/26/2006 | Hideshi Hattori | CU-5102 RJS |

CONFIRMATION NO. 7751

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Title: Method for producing cell culture substrate and apparatus for producing cell culture substrate

Publication No. US-2007-0141697-A1

Publication Date: 06/21/2007

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